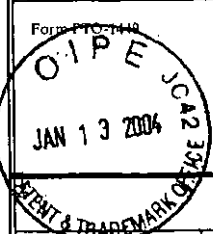


Form PTO-449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. M122-1694		SERIAL NO. 09/885,393		
<div style="text-align: center;">  <p>LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)</p> </div>				APPLICANT Richard Holscher et al.				
				FILING DATE June 19, 2001		GROUP 1756		
U.S. PATENT DOCUMENTS								
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
KAD	AA	6,518,122	02/03	Chan, et al.	438	257		
KAD	AB	6,492,688	12/02	Ilg (ILG)	257	369		
KAD	AC	6,373,114	04/02	Jeng, et al.	257	413		
KAD	AD	2001/0019868	09/01	Gonzalez, et al.	438	275		
KAD	AE	6,503,818 B1	01/03	Jang	438	584		
KAD	AF	6,486,061 B1	11/02	Xia, et al.	438	680		
KAD	AG	6,486,057 B1	11/02	Yeh, et al.	438	633		
KAD	AH	6,465,372 B1	10/02	Xia, et al.	438	787		
KAD	AI	6,444,593 B1	09/02	Ngo, et al.	438	788		
KAD	AJ	6,436,808 B1	08/02	Ngo, et al.	438	623		
KAD	AK	6,435,943 B1	08/02	Chang, et al.	451	28		
KAD	AL	6,429,115 B1	08/02	Tsai, et al.	438	622		
KAD	AM	6,284,677 B1	09/01	Hsiao, et al.	438	783		
KAD	AN	6,030,901	02/00	Hopper, et al.	438	711		
FOREIGN PATENT DOCUMENTS								
		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
KAD	AM	8046186	02/96	JP	—	—	abstract	
KAD	AN	8046188	02/96	JP	—	—	abstract	
KAD	AO	7201716	08/95	JP	—	—	abstract	
KAD	AP	6232113	08/94	JP	—	—	abstract	
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)								
KAD	AR		Wolf, S., "Silicon Processing for the VLSI Era," Vol. 1, pps. 407-413.					
KAD	AS		Wolf, S., "Silicon Processing for the VLSI Era", Vol. 2, pgs. 48-49 and 435.					
EXAMINER				DATE CONSIDERED				
K. Duda				2-19-04				
<p>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</p>								

EL979978767

U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE				ATTY. DOCKET NO. M122-1694		SERIAL NO. 09/885,393	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT Richard Holscher et al.			
				FILING DATE June 19, 2001		GROUP 1756	
U.S. PATENT DOCUMENTS							
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
KUD	AA	6,133,618	10/00	Steiner	257	646	
KUD	AB	5,994,217	11/99	Ng	438	636	
KUD	AC	5,985,519	11/99	Kakamue et al.	430	313	
KUD	AD	5,747,388	05/98	Kusters, et al.	438	723	
KUD	AE	5,639,687	06/97	Roman, et al.	438	69	
KUD	AF	5,498,555	03/96	Lin	438	302	
KUD	AG	2001/0003064	06/01	Ohto	438	687	
KUD	AH	2003/0013311	01/03	Chang, et al.	438	704	
	AI						
	AJ						
	AK						
	AL						
	AM						
	AN						
FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Subclass	Translation
							Yes No
	AM						
	AN						
	AO						
	AP						
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
	AR						
	AS						
EXAMINER				DATE CONSIDERED			
K. Duda				2-19-04			
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							